

REPORT DOCUMENTATION PAGE

AFRL-SR-BL-TR-01-

0125

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1. AGENCY USE ONLY (Leave blank)		2. REPORT DATE	3. REPORT TYPE AND DATES COVERED 1 March 1998 to 28 February 1999	
4. TITLE AND SUBTITLE Graphics Equipment for Real Time Animation and Virtual Design of Electronic Materials Processes			5. FUNDING NUMBERS F49620-98-1-0346	
6. AUTHOR(S) Dr. Vishwanath Prasad				
7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES) State University of New York Stony Brook, NY 11794-2300			8. PERFORMING ORGANIZATION REPORT NUMBER	
9. SPONSORING/MONITORING AGENCY NAME(S) AND ADDRESS(ES) AFOSR 801 N. Randolph Street, Room 732 Arlington, VA 22203-1977			10. SPONSORING/MONITORING AGENCY REPORT NUMBER F49620-98-1-0346	
11. SUPPLEMENTARY NOTES				
12a. DISTRIBUTION AVAILABILITY STATEMENT Approved for Public Release.			<p style="text-align: center;">AIR FORCE OFFICE OF SCIENTIFIC RESEARCH (AFOSR) NOTICE OF TRANSMITTAL DTIC. THIS TECHNICAL REPORT HAS BEEN REVIEWED AND IS APPROVED FOR PUBLIC RELEASE LAW AFR 100-12. DISTRIBUTION IS UNLIMITED.</p>	
13. ABSTRACT (Maximum 200 words) The Objective of this research equipment grant was to purchase computing equipment to upscale the local graphics infrastructure and to accomplish successfully the research tasks of AFOSR/DARPA MURI project on "Integrated, Intelligent Modeling, Design and Control of Crystal Growth Processes." As proposed, Silicon Graphics Onyx 2 Infinite Reality Graphics Rack System has been purchased and networked with other computers in the Process Modeling Laboratory. This computer has greatly enhanced the graphics capability in this laboratory and is being successfully used for process animation. This has allowed interaction with the computer science faculty and students to further expand our research program for virtual design and prototyping. The new facility is also helpful to some other NSF and industrial projects.				
14. SUBJECT TERMS			15. NUMBER OF PAGES 2	
			16. PRICE CODE	
17. SECURITY CLASSIFICATION OF REPORT		18. SECURITY CLASSIFICATION OF THIS PAGE	19. SECURITY CLASSIFICATION OF ABSTRACT	20. LIMITATION OF ABSTRACT

20010226 024

NM

DURIP 98/99

**GRAPHICS EQUIPMENT FOR REAL TIME
ANIMATION AND VIRTUAL DESIGN OF ELECTRONIC
MATERIALS PROCESSES**

AFOSR Grant No. F 496209810346

Grant Period: 3/1/98 – 2/28/99

Final Report

May 1999

PI: Dr. Vishwanath Prasad, Professor

Co-PI: Dr. Hui Zhang, Assistant Professor

State University of New York

Stony Brook, NY 11794-2300

Final report

The objective of this research equipment grant was to purchase computing equipment to upscale the local graphics infrastructure and to accomplish successfully the research tasks of AFOSR/DARPA MURI project on "Integrated, Intelligent Modeling, Design and Control of Crystal Growth Processes." As proposed, Silicon Graphics Onyx 2 Infinite Reality Graphics Rack System has been purchased and networked with other computers in the Process Modeling Laboratory. This computer has greatly enhanced the graphics capability in this laboratory and is being successfully used for process animation. This has allowed interaction with the computer science faculty and students to further expand our research program for virtual design and prototyping. The new facility is also helpful to some other NSF and industrial projects.